

20/Evt. ①
w/ Amcdt. E
Jherlepa
Patent 4-18-02



Attorney's Docket No.: 042390.P4220

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:)
Bohr, Mark T.)
U.S. Serial No: 09/002,178)
Filed: December 31, 1997)
For: WAFER PASSIVATION)
STRUCTURE AND METHOD OF)
FABRICATION)

Examiner: Guerrero, Maria F.
Art Unit: 2822

Assistant Commissioner for Patents
Washington, D.C. 20231

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AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed November 29, 2001. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on March 28, 2002
Date of Deposit

Teresa Edwards
Name of Person Mailing Correspondence
Teresa Edwards March 28, 2002
Signatur Date